

UCSF May Submit 1 Application

Internal Deadline: 11:59 PM, Wednesday, November 16, 2022

PLEASE FORWARD THIS ANNOUNCEMENT TO ALL APPROPRIATE FACULTY AND RESEARCH ADMINISTRATORS

WHAT: CDC NIOSH Occupational Safety and Health Education and Research Centers (T42)
(<https://grants.nih.gov/grants/guide/rfa-files/RFA-OH-23-003.html>)

REQUEST FOR APPLICATIONS NUMBER: RFA-OH-23-003

PURPOSE:

- To provide high-quality interdisciplinary graduate and post-graduate training, research training, continuing education, and outreach in the core occupational safety and health disciplines of industrial hygiene, occupational health nursing, occupational medicine, and occupational safety, as well as allied disciplines.

ELIGIBILITY:

- Any individual(s) with the skills, knowledge, and resources necessary to carry out the proposed research as the Program Director(s)/Principal Investigator(s) (PD(s)/PI(s)) is invited to work with his/her organization to develop an application for support. Individuals from underrepresented racial and ethnic groups as well as individuals with disabilities are always encouraged to apply.
- Trainees supported by NIOSH funding must be United States citizens, non-citizen nationals or permanent U.S. residents.

BUDGET AND PROJECT PERIOD:

- Award Budget: up to \$1,800,000 total costs per year
 - Please see RFA for budget breakdown by Component.
 - UCSF indirect cost policy will apply except for non-federal entities.
- Project Period: 3 years

NUMBER OF APPLICATIONS UCSF MAY SUBMIT: 1

APPLICATION TYPES ALLOWED: New, Renewal, Resubmission, Revision

CURRENTLY FUNDED INSTITUTIONS: [18](#)

DUE DATES:

- **Internal: 11:59 PM, Wednesday, November 16, 2022.** If multiple groups submit an LOI, an additional pre-application will be due Wednesday, November 30, 2023.
- **PIs submit directly to the LSP; RMS does not get involved unless and until you are nominated.**
- Sponsor: Monday, January 09, 2023

Submit the attached Letter of Intent (LOI) by 11:59 PM, November 16, to:
limitedsubmissions@ucsf.edu

To qualify for UCSF Limited Submission Program opportunities, applicants must have a paid UCSF appointment either at the time of application or anticipated by the time of award.

The LSP is a selection process, not an award process. As the LSP is under significant time constraints, all reviewer feedback is optional. We encourage you to seek other avenues for proposal feedback.

For information on all current LSOs, please visit: <http://rdo.ucsf.edu/limited-submission-program-lsp>

Sent by Avity Norman on behalf of the Limited Submission Program (LSP) within the Research Development Office (RDO).